

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/798,967	<b>Applicant(s)/Patent under Reexamination</b> CHOI, KWONG-KIT
	<b>Examiner</b> Mary Zettl	<b>Art Unit</b> 2875

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner